

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re application of

: **Confirmation No. 4423**

Tomohiro OKUMURA et al.

: Docket No. 2001-1089A

Serial No. 09/918,823

: Group Art Unit 2821

Filed August 1, 2001

: Examiner T. Phan

PLASMA PROCESSING METHOD  
AND APPARATUS THEREOF

:

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of  
May 21, 2003.

The fee of \$950.00 is

(X) submitted herewith.

() to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

() Small entity status of this application is established by a Small Entity Status Assertion  
which

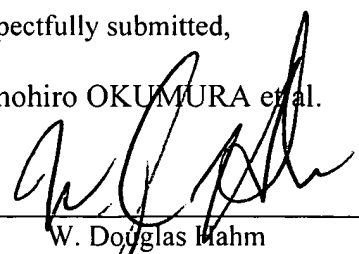
() is enclosed.

() has been previously submitted.

Respectfully submitted,

Tomohiro OKUMURA et al.

By

  
W. Douglas Mahm  
Registration No. 44,142  
Attorney for Applicants

11/26/2003 ZJUHR1 00000013 09918823

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November 21, 2003

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DEC - 3 2003

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